

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Takehiro UEDA, et al.

SERIAL NO: 10/509,338

GAU: 1792

FILED: October 8, 2004

EXAMINER: DAHIMENE, M.

FOR: METHOD FOR SUPPRESSING CHARGING OF COMPONENT IN VACUUM PROCESSING
CHAMBER OF PLASMA PROCESSOR AND PLASMA PROCESSOR

**REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a **second** month extension of time be granted to February 7, 2008 for

- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☒ filing a Request for Continued Examination. A response to the final rejection was filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$340.00 is being made by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. **15-0030**.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
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